



6/17/04

Attorney/Docket No. 34003.30
Customer No. 27683
Bhw

GP 17628

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Wayne A. Weimer § Docket No.: 34003.30
Serial No.: 09/852,992 § Examiner: Timothy H. Meeks
Filed: May 10, 2001 § Art Unit: 1762
Entitled: System and Method for Controlling §
Deposition Parameters in Producing §
a Surface to Tune the Surface's §
Plasmon Resonance Wavelength §

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-1450

In compliance with the duty of disclosure under 37 CFR §1.56, and in accordance with the practice under 37 CFR §1.97 and §1.98, the Examiner's attention is directed to the documents listed on the enclosed modified Form PTO-1449. No inference should be made that the cited references are in fact material, are in fact prior art, or that no better art exists.

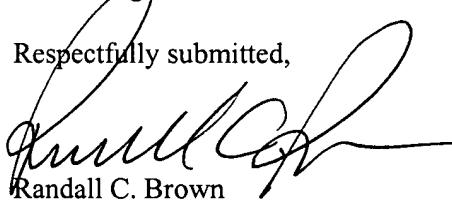
This Information Disclosure Statement is being filed more than three months after the United States filing date and after the mailing date of the first Office Action on the merits, but before the mailing date of a Final Action under §1.113 or Notice of Allowance under §1.311 (37 CFR §1.97(c)).

Accompanying this transmittal is the \$180.00 fee set forth in 37 CFR §1.17(p) for submission of an Information Disclosure Statement under §1.97(c).

The Commissioner is hereby authorized to charge any additional fees which may be required or credit any overpayment to Deposit Account 08-1394.

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Respectfully submitted,


Randall C. Brown

Registration No. 31,213

06/21/2004 EAREGAY1 00000130 09852992

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Date: 6/16/04

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This paper and fee are being deposited with the U.S. Postal Service Express Mail Post Office to Addressee service under 37 CFR §1.10 on the date indicated above and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450	
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<u>Ellen Lovelace</u> Signature of person mailing paper and fee	

<p>In place of PTO-1449 Form</p> <p>P F</p> <p>O JUN</p> <p>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</p> <p>(use as many sheets as necessary)</p> <p><i>PATENT & TRADEMARK OFFICE</i></p>	<p>U. S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE</p>	<p>Complete if Known</p> <hr/> <table border="1" style="width: 100%; border-collapse: collapse;"> <tr> <td style="width: 45%;">Application Number</td> <td>09/852,992</td> </tr> <tr> <td>Filing Date</td> <td>May 10, 2001</td> </tr> <tr> <td>Applicant(s)</td> <td>Wayne A. Weimer</td> </tr> <tr> <td>Art Unit</td> <td>1762</td> </tr> <tr> <td>Examiner Name</td> <td>Timothy H. Meeks</td> </tr> </table> <hr/> <p>1 SHEET 1 OF 1</p> <p>Attorney Docket Number</p> <p>34003.30</p>			Application Number	09/852,992	Filing Date	May 10, 2001	Applicant(s)	Wayne A. Weimer	Art Unit	1762	Examiner Name	Timothy H. Meeks
Application Number	09/852,992													
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OTHER PRIOR ART		
Examiner's Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article, title of the item, date, page(s), volume-issue number(s), publisher, city/country where published
		Sennett, R. S. et al., "The Structure of Evaporated Metal Films and Their Optical Properties," Journal of the Optical Society of America, Vol. 40, No. 4, April 1950, pp. 203-211.

Examiner Signature		Date Considered	
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include a copy of this form with next communication to applicant.



PATENT / DOCKET NO. 34003.30
Customer No. 000027683

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Wayne A. Weimer	§ Docket No.: 34003.30
Serial No.:	09/852,992	§ Examiner: Timothy H. Meeks
Filed:	May 10, 2001	§ Art Unit: 1762
Entitled:	System and Method for Controlling Deposition Parameters in Producing a Surface to Tune the Surface's Plasmon Resonance Wavelength	§

EXPRESS MAIL CERTIFICATE

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Express Mail Number: EV 333443407 US

Date of Deposit: June 16, 2004

I hereby certify that the following attached papers and fee:

1. Response to Office Action Mailed March 16, 2004;
2. Supplemental Information Disclosure Statement, Form 1449 and 1 reference;
3. check in the amount of \$180.00; and
4. return postcard

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22313-1450.

Ellen Lovelace

Typed or Printed Name

Ellen Lovelace

Signature